

Message Text

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PAGE 01 STATE 063995
ORIGIN EA-06

INFO OCT-01 ISO-00 SS-14 ONY-00 /021 R

DRAFTED BY EA:EHHEGINBOTHAM:LRR
APPROVED BY EA - EHHEGINBOTHAM
EA/J - MR. PLATT
DESIRED DISTRIBUTION
EA ONLY

-----093399 132257Z /63
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FM SECSTATE WASHDC
TO AMEMBASSY TOKYO IMMEDIATE

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LIMDIS

E.O. 11652: N/A

TAGS: EGEN, BTRA, JA

SUBJECT: US SEMI-CONDUCTOR INDUSTRY VISIT TO JAPAN; TOKYO
3986 AND 4006
REF: HEGINBOTHAM-SHINN DISCUSSION IN TOKYO

1. PER REF DISCUSSION, HEGINBOTHAM CONTACTED WARREN DAVIS AT FAIRCHILD, AND HAS DETERMINED IT WOULD BE HIGHLY DESIRABLE FOR SHINN TO VISIT MOUNTAIN VIEW, CALIFORNIA ON WAY BACK TO WASHINGTON. WOULD BE IDEAL IF SHINN COULD ARRIVE SAN FRANCISCO WEDNESDAY EVENING, AND BE AVAILABLE FOR MEETINGS WITH KEY INDUSTRY REPRESENTATIVES ON THURSDAY. DAVIS LEAVES FOR INDONESIA ON FRIDAY, SO THURSDAY MEETINGS ARE BY FAR MOST DESIRABLE.

2. REQUEST THAT SHINN ADVISE EA BY IMMEDIATE CABLE WHETHER
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HE COULD MAKE WEDNESDAY ARRIVAL. REQUEST SHINN ALSO TELEX DAVIS AT THE FOLLOWING TELEX DESIGNATION: FASEMCO-MTNV:348-473. IF SHINN UNABLE TO MAKE THURSDAY MEETINGS, HE CAN MAKE ALTERNATIVE ARRANGEMENT VIA TEXLEX DIRECTLY WITH DAVIS.

3. ON ARRIVAL IN SAN FRANCISCO, SHINN SHOULD CONTACT DAVIS AT HOME: (408) 867-7340, OR OFFICE (415) 962-5011. VANCE

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Message Attributes

Automatic Decaptioning: Z
Capture Date: 01 jan 1994
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Original Handling Restrictions: ONLY
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